

Notice of References Cited	Application/Control No. 10/707,979		Applicant(s)/Patent Under Reexamination DENTON ET AL.	
	Examiner MARK A. FLEISCHER		Art Unit 3624	Page 1 of 2

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-7,464,147 B1	12-2008	Fakhouri et al.	709/223
*	C	US-6,701,201 B2	03-2004	Hegde et al.	700/107
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*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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